

Response under 37 C.F.R. § 1.116  
Expedited Procedure  
Examining Group 1765

PATENT  
ATTORNEY DOCKET NO. 041501-5415

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Il Gweon KIM )  
)  
Application No.: 09/987,738 )  
)  
Filed: November 15, 2001 )  
)  
For: METHOD FOR FORMING SILICON )  
QUANTUM DOTS AND METHOD FOR )  
FABRICATING NONVOLATILE )  
MEMORY DEVICE USING THE SAME )

Confirmation No.: 7445  
Group Art Unit: 1765  
Examiner: B. Tran

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TC 1700

Commissioner for Patents  
U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window, **Mail Stop AF**  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

**AMENDMENT UNDER 37 C.F.R. § 1.116**

In response to the Final Office Action dated September 23, 2003 (Paper No. 6), the period for response to which extends through December 23, 2003, entry of the following amendments is respectfully requested to place the application in clear condition for allowance or, alternatively, in better form for appeal.